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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

MAIL STOP: AMENDMENT

Hiroshi SOTOZAKI et al.

Confirmation No. 8916

Serial No. 10/774,489

Docket No. 2004 0208

Filed February 10, 2004

Group Art Unit 1763

METHOD AND APPARATUS FOR POLISHING A SUBSTRATE

Examiner S. MACARTHUR

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 COMMISSIONER IS AUTHORIZED OF CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action mailed March 24, 2005, please amend the above-identified application as follows: